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RICHTER et al.

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U. S. PATENT DOCUMENTS

EXAMINER	PATENT NUMBER	PATENT DATE	NAME	DUASS	SUBCLASS	FILING DATE
INITIAL	**5,140,605	August 18, 1992	Thomas et al.	322	50	

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* Described in the specification.

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K.H. Park, "Fabrication and Transmission Experiments of Distributed Feedback Lasers Modules for 2.5 Gb/s Optical Transmission Systems," published in Optical and Quantum Electronics 27 (1995), 547-552.

*Richter, "Chips mit Zukunftspotential," [Chips with Future Potential], interim results of the Telekom Research Project OEIC, Telekom Vision 7/93, pp. 41-47.

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EXAMINER	James Dayle	DATE CONSIDERED 12/16/67			
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